

Title (en)
Spray system

Title (de)
Sprühsystem

Title (fr)
Système de pulvérisation

Publication
EP 2008722 A3 20091202 (DE)

Application
EP 08002784 A 20080215

Priority
DE 102007030155 A 20070627

Abstract (en)
[origin: EP2008722A2] The system (1) has a control device (4) for continuously controlling a gas supply (9), and a hook-shaped selection unit (3), which is detachably and movably attached at the system in front of a nozzle (2). The breadth of the selection unit is adjustable, and a storage chamber (5) is provided for a product, where the storage chamber stands in connection with a product supply (8). The control device is formed as an axially movable needle-shaped control unit within an inner cone of the nozzle. The selection unit has a splash guard, and the nozzle is exchangeable. An independent claim is also included for a kit with a spraying system.

IPC 8 full level
B05B 11/06 (2006.01)

CPC (source: EP US)
A45D 19/012 (2021.01 - EP); **A45D 19/02** (2013.01 - EP US); **B05B 15/68** (2018.01 - EP); **A45D 2200/057** (2013.01 - EP);
B05B 7/2424 (2013.01 - EP)

Citation (search report)

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- [X] KR 100650291 B1 20061130 - SFC CO LTD [KR]
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- [Y] US 2004222315 A1 20041111 - HABATJOU JACQUES [FR]
- [Y] EP 0208247 A1 19870114 - NIPPON TANSAN GAS CO LTD [JP], et al
- [Y] US 2002004942 A1 20020110 - BRYAN BRUCE [US]
- [Y] EP 1787725 A2 20070523 - KYOWA IND CO LTD [JP]

Designated contracting state (EPC)
AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MT NL NO PL PT RO SE SI SK TR

Designated extension state (EPC)
AL BA MK RS

DOCDB simple family (publication)
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